




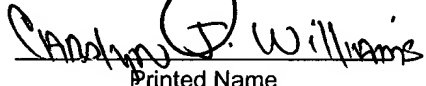
2625

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE	
REPLY TO OFFICE ACTION DATED 08/07/03	
Atty. Docket No. DUPONT1120-1	
Applicants Michael J. Penberth, et al.	
Application Number 09/262,778	Date Filed 03/04/99
Title Electron Beam Blanking Method and System for Electron Beam Lithographic Processing	
Group Art Unit 2625	Examiner Chawan, Sheela C.
Confirmation Number: 9973	

#11 Reconsideration
11/3/03

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

<u>Certificate of Mailing Under 37 C.F.R. §1.8</u>
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22312-1450 on <u>October 21</u> , 2003.
 Signature
 Printed Name

In response to the Official Action mailed August 7, 2003, Applicants respectfully request that the Examiner reconsider the rejections of the Claims in view of this reply.

RECEIVED

OCT 28 2003

Technology Center 2600